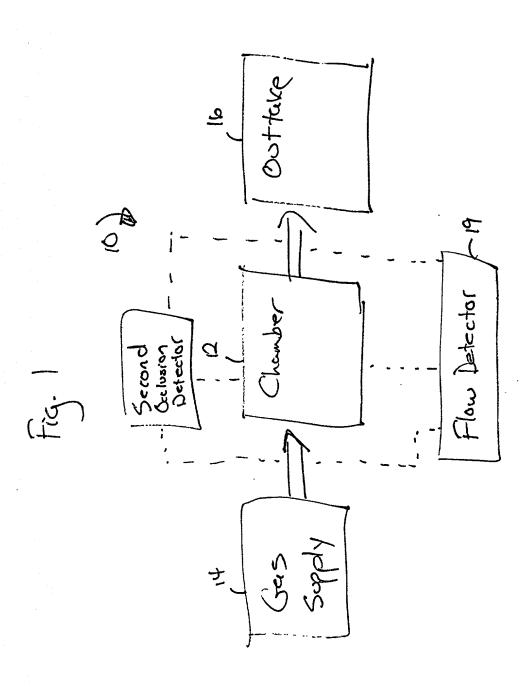
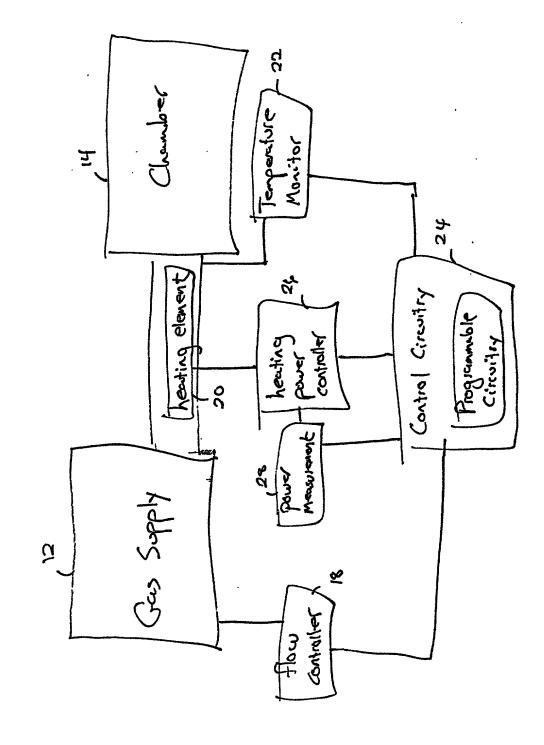
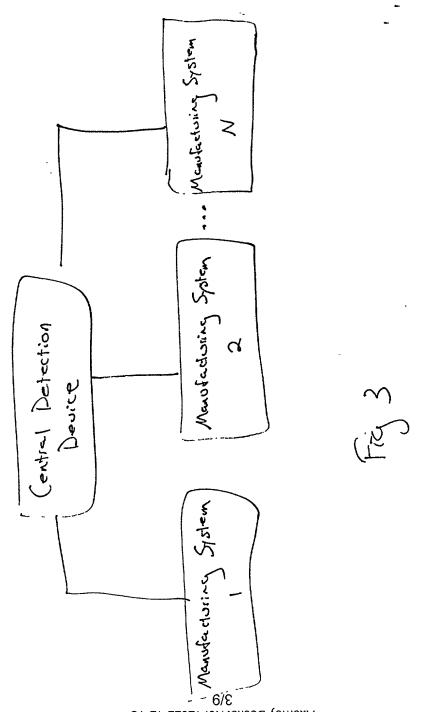
Serial No. 09/943,569 Inventor: Bradley Dale Mitchell For: System and Method for Removing Deposited Materials From Within a Semiconductor Fabrication Device Attorney Docket No. 12522-12-1C 1/9



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a Semiconductor Fabrication Device Attorney Docket No. 12522-12-1C

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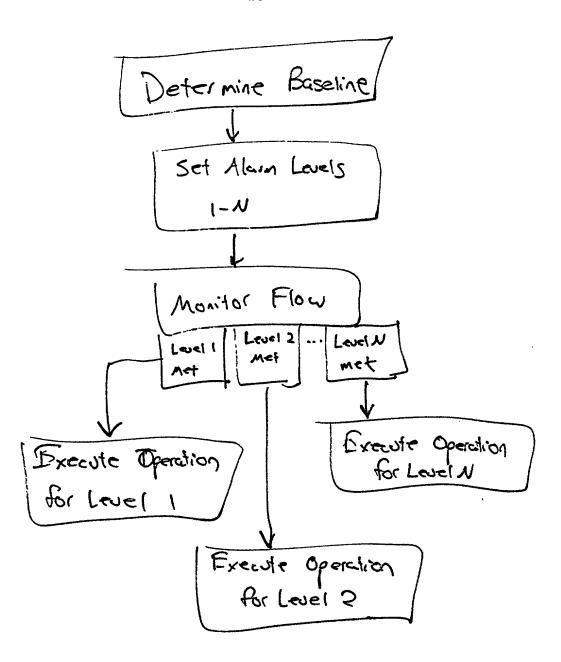


Fig 4

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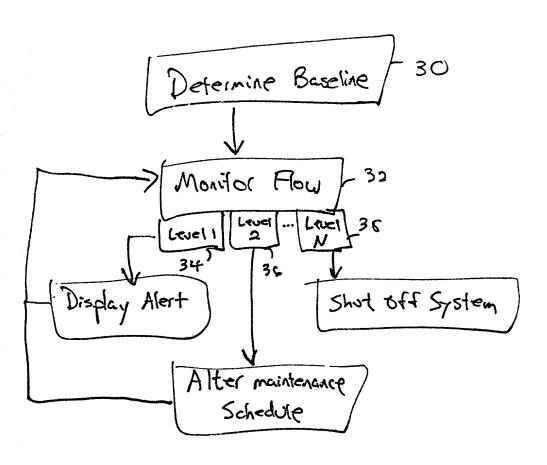
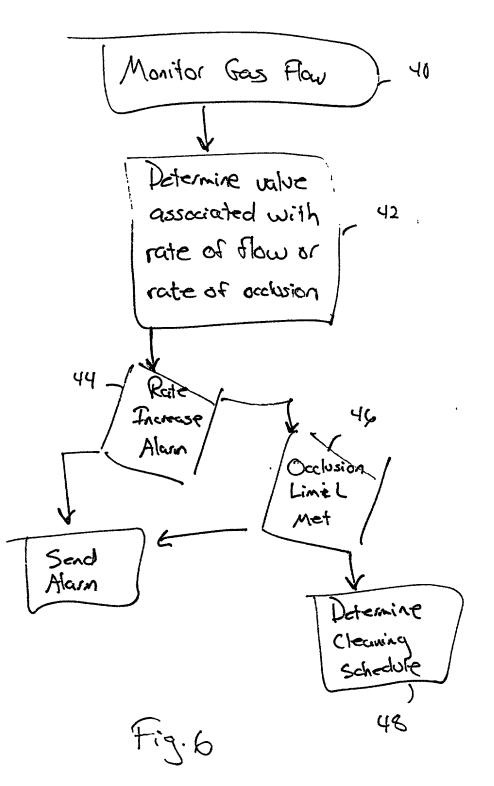


Fig. 5

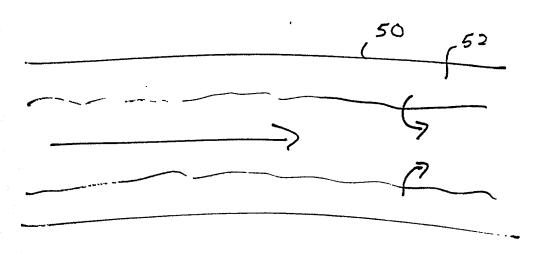
Śerial No. 09/943,569 Inventor: Bradley Dale Mitchell

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Serial No. 09/943,569
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Šerial No. 09/943,569 Inventor: Bradley Dale Mitchell

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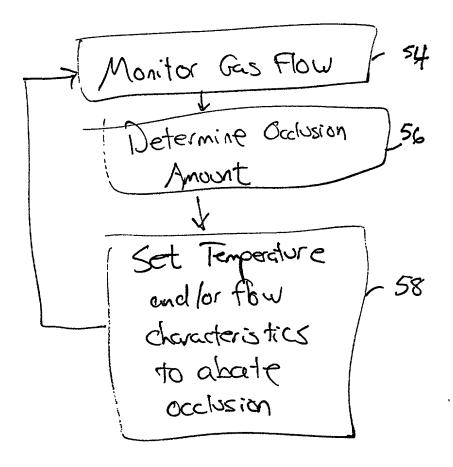


Fig. 8

Serial No. 09/943,569

Inventor: Bradley Dale Mitchell
For: System and Method for Removing Deposited Materials From Within

a Semiconductor Fabrication Device Attorney Docket No. 12522-12-1C

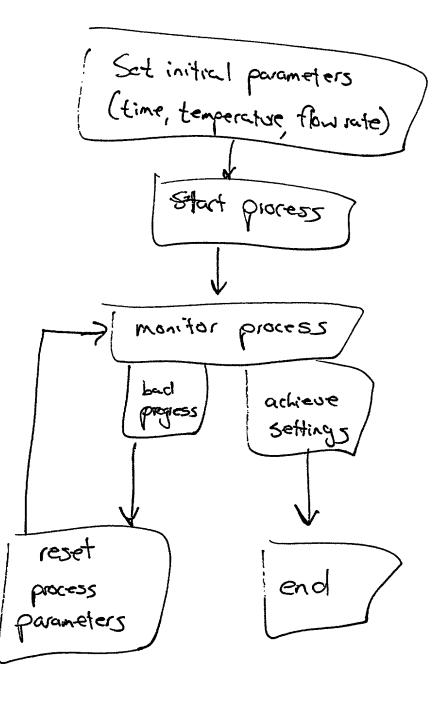


Fig. 9